

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	("mems" or micro adj electromechanical) and substrate and control adj electrode and driving adj circuit and sensor adj electrode and sensor adj circuit and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 15:26
L2	1498	257/414-415.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 15:33
L3	2721	257/431-432.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 15:59
L4	1	((("mems" or micro adj electro adj mechanical adj system or micro adj electromechanical) and substrate and control adj electrode and driving adj circuit and sensor adj electrode and sensor adj circuit and memory and processor).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 16:00
S1	2	("mems" or micro adj electro adj mechanical adj system) and substrate and control adj electrode and driving adj circuit and sensor adj electrode and sensor and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 15:59
S2	20	("mems" or micro adj electro adj mechanical adj system) and substrate and control adj electrode and (driving adj circuit or driver) and sensor and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:08
S3	2	("mems" or micro adj electro adj mechanical adj system) and substrate and control adj electrode and driving adj circuit and sensor adj electrode and sensor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 09:20
S4	813	("mems" or micro adj electro adj mechanical adj system) and substrate and electrode and sensor and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 09:28
S5	2	("2002110312").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/15 09:29
S6	2	("20020071169").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/15 09:30

S7	2	("mems" or micro adj electro adj mechanical adj system) and substrate and control adj electrode and driving adj circuit and sensor adj electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 10:15
S8	2	("mems" or micro adj electro adj mechanical adj system) and control adj electrode and driving adj circuit and sensor adj electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 10:15
S9	8	("mems" or micro adj electro adj mechanical adj system) and substrate and control adj electrode and sensor adj electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 15:02
S10	2	("6550330" "6581465").PN. OR ("6763718").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/15 10:16
S11	2	("6550330" "6581465").PN. OR ("6763718").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/15 10:17
S12	2	("6546798").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/15 10:17
S13	1547	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 10:21
S14	813	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor and memory and processor and electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 14:40
S15	0	("mems" or micro adj electro adj mechanical adj system) and nippon adj telegraph adj telephone.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 14:42
S16	195	("mems" or micro adj electro adj mechanical adj system) and nippon.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 14:42
S17	2	("20030169962").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/15 15:03
S18	2	("6597827").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/15 15:03
S19	3	("mems" or micro adj electro adj mechanical adj system) and sensor adj electrode and sensor adj circuit and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 15:40

S20	640	("mems" or micro adj electro adj mechanical adj system) and sensor same detect same (motion or movement)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 15:41
S21	189	("mems" or micro adj electro adj mechanical adj system) and sensor same detect same (motion or movement) and substrate and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 15:42
S22	62	("mems" or micro adj electro adj mechanical adj system) and sensor same detect same (motion or movement) and substrate and memory and processor and electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 16:16
S23	4	("5992233" "6158280" "6373265"). PN. OR ("6504385").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/15 15:47
S24	357	("mems" or micro adj electro adj mechanical adj system) and sensor same detect same (motion or movement) and substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/15 16:16
S25	23	nippon adj telegraph near2 telephone. as. and ("mems" or micro adj electro adj mechanical adj system)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:09
S26	40	urano-masami.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:08
S27	6	ishii-hiromu.in. and ("mems" or micro adj electro adj mechanical adj system)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:10
S28	5	shimamura-toshishige.in. and ("mems" or micro adj electro adj mechanical adj system)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:11
S29	9	tanabe-yasuyuki.in. and ("mems" or micro adj electro adj mechanical adj system)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:11
S30	5	sakata-tomomi.in. and ("mems" or micro adj electro adj mechanical adj system)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 11:11
S31	3	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor adj electrode and sensor adj circuit and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 12:25

S32	1567	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor and memory and processor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 12:26
S33	821	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor and memory and processor and electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 12:27
S34	815	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor and memory and processor and electrode and (control or driver or driving)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 12:28
S35	291	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor same (motion or movement) and memory and processor and electrode and (control or driver or driving)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 14:32
S36	2	("6232140").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/29 12:40
S37	1653	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor same (motion or movement)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 14:40
S38	8	("mems" or micro adj electro adj mechanical adj system) and substrate and sensor adj electrode same (motion or movement)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/29 14:40
S39	1	"20040063325".pn. and "909"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 10:46
S40	1	"20040063325".pn. and "221"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 10:49
S41	1	"20040063325".pn. and "105a"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/30 10:50